

Evaluation of Carrier Capture Times for Very Thin InGaAs/InP Quantum-Wells

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Conventional and time-resolved photoluminescence measurements were conducted on an InGaAs/InP quantum-well structure with six quantum-wells, each grown for a different period of time varying between 1 and 20 seconds. Calculations of the lowest transition energy were carried out assuming several types of interfaces with varying compositions and thicknesses showing that the barrier for emission of an electron is always smaller than that of a hole. The experimentally observed photoluminescence peaks are within the small energy range predicted by theory. Combining then the calculated electron barriers with the measured lifetimes, one was able to determine the capture times of electrons into the quantum-wells using the Principle of Detailed Balance for capture and emission. The capture times obtained range from 2 to 14ps.

The fast development of devices based on quantum-well structures has greatly raised the interest on the evaluation of carrier capture times in quantum-wells of different materials and widths. Lasers based on such structures depend on an efficient carrier capture process^[1-3] while photodetectors rely on long capture times in order to efficiently collect the current^[4].

On the theoretical point of view, the interest lies both on the approach taken to tackle the capture process which is intermediated by LO phonons and on the prediction of capture times for different systems. The classical picture adopted in the late 70's and early 80's

resulted in rather fast capture times for quantum-wells thicker than the mean-free-path of the carriers^[5,6]. In the mid 80's a quantum-mechanical approach was introduced which predicted oscillations on the capture times with quantum-well (QW) thicknesses^[7,8].

Experimentally, capture times are obtained indirectly, often through the measurement of either the decay of the barrier photoluminescence (PL) signal or the rise of the QW PL. In the literature one can find capture times varying from 0.1 to 20 ps depending on the sample configuration and experimental technique used^[9-11]. In any case, frequently the theoretical results do not agree with the measured data. However, the oscillations in the capture times with QW thickness has been experimentally observed for the

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$\text{Al}_x\text{Ga}_{1-x}\text{As}/\text{GaAs}$ system^[1].

In this letter we present a simple approach using the Principle of Detailed Balance between capture and emission processes to determine capture times in extremely thin quantum-wells of an $\text{In}_{0.53}\text{Ga}_{0.47}\text{As}/\text{InP}$ multiple-quantum-well (MQW) structure consisting of a series of quantum-wells of thicknesses varying from 3 to 50 Å. The Detailed Balance analysis not only clearly demonstrates that the emission of carriers out of a well or in other words, the transfer of carriers from one well to a neighboring one, takes place via the least bound particle and not via excitons, but also provides capture times which are in excellent agreement with other recent published results for the $\text{GaAs}/\text{Al}_x\text{Ga}_{1-x}\text{As}$ system^[11].

The sample used was grown at 600°C and 50 mbar on a Sn-doped InP substrate using 2 seconds growth interruption on both interfaces. First, an InP buffer layer of 250nm was deposited, followed by an $\text{In}_{0.53}\text{Ga}_{0.47}\text{As}$ lattice-matched thick reference layer. Then, a series of six $\text{In}_{0.53}\text{Ga}_{0.47}\text{As}$ quantum-wells separated by 200 Å InP barriers was grown. Finally, a 350 Å thick InP cap layer was deposited. Further details about the sample structure can be found in Ref. 12.

Conventional PL was performed between 2 and 450 K using the 5145 Å line of the Ar^+ laser. A nitrogen-cooled germanium photodiode was used with lock-in detection. For the time-resolved PL experiments a pulsed Ti:sapphire laser was used with excitation wavelength of 9600 Å. The signal was detected by a Hamamatsu streak camera. The temporal resolution of the experiment was limited by the 6 ps laser pulse width. The excitation power used on both PL experiments was around 100 W/cm².

Fig. 1 shows a 2K PL spectrum of the sample where several PL peaks originating in different quantum-wells can be observed. The associated number of monolayers (ML) is indicated in the figure. One can distinguish, for instance, two PL peaks coming from the QW grown for five seconds, each one corresponding to a different

number of ML's, the so-called extended monolayer flat-islands. Excitons under certain circumstances are allowed to move from one of these islands to another within the same QW (intra-well transfer). This type of migration has already been extensively discussed in a previous publication^[13]. This communication will be concentrated on the emission out of a QW towards a neighboring one.

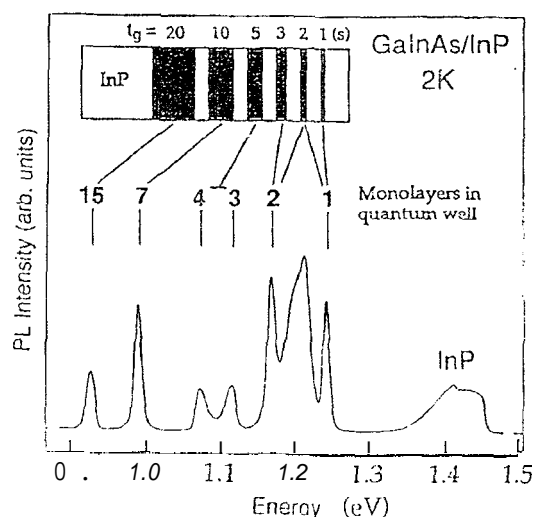


Figure 1: Photoluminescence spectra at 2K of the investigated $\text{In}_{0.53}\text{Ga}_{0.47}\text{As}/\text{InP}$ multiple-quantum-well structure. For each nominal quantum-well grown according to the growth sequence, the spectra consists of PL emission lines which are split into multiplets. The sample structure and thickness of the quantum-well corresponding to each of the luminescence lines are shown in the insert.

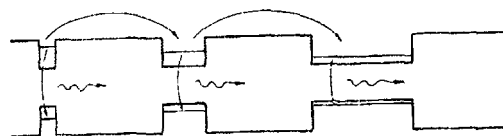


Figure 2: Scheme of the emission, radiative recombination and inter-well transfer processes occurring in the investigated $\text{In}_{0.53}\text{Ga}_{0.47}\text{As}/\text{InP}$ multiple-quantum-well structure.

The thinner the QW is the closer the electron and the hole energy levels are to the corresponding InP barrier ones. Therefore, the energy barrier for carriers to be emitted out of the QW is smaller for the thinner wells. This description is schematically pictured in figure 2.

As one increases the temperature, the PL starts to quench. The temperature for which the quenching of

the PL sets n will be higher the thicker the well. These characteristic temperatures T' can be determined from an Arrhenius plot for each QW and should indirectly correspond to the emission rate of a particular QW. At $T = T'$, one can then say that the emission and recombination rates are equal. Putting it in another way, at $T = T'$

$$e_n = \tau_{\text{rec}}^{-1} \quad (1)$$

where e_n is the emission rate and T_{rec} the recombination time.

Simultaneously with the decrease of the PL intensity of one QW the PL signal of the thicker neighboring QW increases. This implies that the PL quenching process is essentially due to emission of carriers out of the QW and their subsequent capture in a neighboring QW. Since the emission out of a QW is evidenced by both the quenching of the PL signal and by the capture of carriers by another QW, compiling these characteristic temperatures with the activation energy for emission, one should be able to easily correlate the emission and capture rates. Using the Principle of Detailed Balance one can write:

$$e_n = c_n \exp(-\Delta E/kT), \quad (2)$$

where c_n is the capture rate. At $T = T'$ Eq. (2) can be rewritten as:

$$r_{\text{em}} = \tau_{\text{cap}} \exp(-\Delta E/kT). \quad (3)$$

The emission rates can be determined by measuring the recombination time r_{em} at T' . The activation energy ΔE can be calculated from the confinement energies for electrons and holes. Consequently, it should be possible to extract capture times for these QW's.

So far one has completely neglected recapture. Carriers emitted out of a QW can move either towards a thinner or a thicker well. In case they migrate in the direction of the thinner QW, they will be immediately reemitted, because the temperature is high enough, and recaptured by the original QW. Therefore, in order to take recapture into account and still use the Principle

of Detailed Balance, one should introduce a factor of 2 on equation (3). The argument to understand this is as follows. Since there are two emission paths, one needs two emitted carriers for one captured carrier. In this way,

$$2\tau_{\text{rec}}^{-1} = r_{\text{em}} \exp(-\Delta E/kT'). \quad (4)$$

Next step is to determine the activation energy ΔE . If one assumes that the carriers are transferred as an exciton, then ΔE is the sum of the barriers for the electron and for the hole, C barriers. Plotting kT' as a function of C barriers one obtains a linear relationship: $kT' = 0.053 C$ barriers. Substituting it in Eq. (4),

$$2\tau_{\text{rec}} = \tau_{\text{cap}}^{-1} \exp(-1/0.053). \quad (5)$$

In order to verify whether the inter-well carrier transfer takes place via excitons or not one can simply use values of τ_{rec} from the literature to evaluate τ_{cap} . Using $\tau_{\text{rec}} = 10 \text{ ns}^{[14]}$ one obtains $r_{\text{em}} < \text{fs}$ which is totally unrealistic. This demonstrates that the inter-well migration occurs via free carriers. Certainly the first particle to move is the least bound one, which has not been determined yet.

Defining ξ , as an energy fraction of the C barriers one can write barriers. Then, Eq. (4) becomes: one can write $\xi = \Delta E/\Sigma$ barriers

$$2\tau_{\text{cap}} = \tau_{\text{rec}} \exp(-\xi/0.053). \quad (6)$$

In calculating ξ , using the envelope function approach several types of interfaces were tested. In addition to the ideal interface, five different plausible structural perturbations were also checked. One of them was the introduction of half a monolayer of InAs on each side of the QW. Others also included different $\text{InAs}_x\text{P}_{1-x}$ monolayer configurations with compositions varying from $x = 0.25$ to $x = 0.75$.

One way of checking the results is to calculate the transition energies as well and compare them with the measured PL peak energies. The result of this procedure is plotted in figure 3. By this method one should

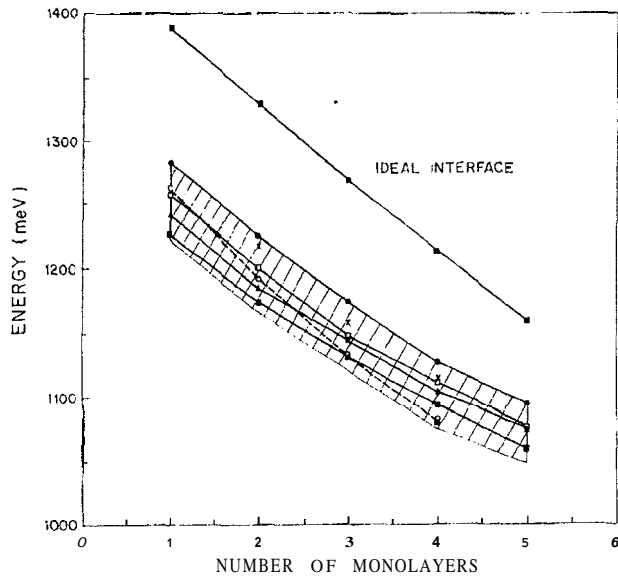


Figure 3: Transition energies vs. the number of monolayers for the investigated $\text{In}_{0.53}\text{Ga}_{0.47}\text{As}/\text{InP}$ multiple-quantum-well structure. The lines are just a guide for the eyes. The solid ones connect calculated points for the same interface perturbation introduced while the dashed line links the experimental points. The crosses refer to a different sample described in the text. The shadowed rectangle embraces the theoretically obtained energy values except for the case of the ideal interface.

be able to know which interface structure approaches the most the one encountered in the sample and to eventually choose the most adequate ξ

In figure 3, the straight solid lines connect the values obtained for the same type of interface and are just a guide for the eyes. The dashed line connects the experimental points obtained from the 2K PL spectra. Also included in the figure, represented by crosses, are the experimental points for another sample grown under similar conditions but containing a stack of 10 QW grown for 6 seconds. The QW's contain islands with 2, 3 and 4 ML's.

Two features are striking in this figure. First, the values calculated for the ideal interface are more than 100 meV higher than the experimental data. Second, the exact interface perturbation introduced is not crucial since they all provide transition energies that follow the same trend and do not differ by much. Also, the perturbation that best simulates the sample structure depends on the number of ML's. The highlight of the

Table I. Calculated range of fraction of energy barrier ξ , for the electrons between the InP barrier and the $\text{In}_{0.53}\text{Ga}_{0.47}\text{As}$ quantum-wells consisting of 1 to 5 monolayers.

	ξ
1ML	(0.19,0.23)
2ML	(0.22,0.25)
3ML	(0.23,0.27)
4ML	(0.26,0.31)
5ML	(0.28,0.33)

figure is that the experimental data for both samples fall within the shadowed rectangle depicted on the figure 3 which embraces all the calculated data.

In addition, the calculations showed that the electron is always the least bound particle, its fraction of the total barrier ξ , ranging from 0.19 to 0.33 for QW's between 1 to 5 monolayers as shown in Table I.

The recombination times were measured from 10K to 210K. At higher temperatures the PL signal was too weak. In this temperature range the recombination time varied between 1 and 4 ns which is in complete accord with recently reported values^[15]. However, to determine r_{∞} from Eq. (5), one is only interested in r_{∞} at $T = T'$. Since T' for QW's of more than 4 monolayers exceeds 210K, τ_{rec} was only measured for QW's of 1 to 4 monolayers. At $T = T'$, r_{∞} was found to equal to 2.0 ± 0.3 ns. Introducing the calculated range of ξ , and measured values of r_{∞} into Eq. (8), one obtains capture times varying from 2 to 14ps.

These values are in excellent agreement with the results published by Blom et al^[14] where they obtained a capture time of 20 ps for a 30 Å thick $\text{Al}_x\text{Ga}_{1-x}\text{As}/\text{GaAs}$ QW and 3 ps for a 50 Å thick QW corresponding to the predicted capture time oscillations. Their results were extracted from the rise time differences of the QW luminescence after direct excitation into the QW and indirect excitation into the $\text{Al}_x\text{Ga}_{1-x}\text{As}$ barrier. Deveaud et al.^[10] claimed that capture times ought to be shorter than 3 ps, which at first sight may disagree with our results. However, it

is in fact the decay time of the barrier PL signal that they say has an upper limit of 3 ps. Those authors extracted the capture time from the decay of the barrier PL signal for an $\text{Al}_x\text{Ga}_{1-x}\text{As}/\text{GaAs}$ QW. The PL decay time refers to the time the carriers take to leave the barrier while the capture time determined here is the time for the carrier to be captured by the lowest QW energy level.

In conclusion, capture times of electrons into $\text{In}_{0.53}\text{Ga}_{0.47}\text{As}/\text{InP}$ QW of thicknesses varying from 3 to 12 Å have been determined to be between 2 and 14 ps. This evaluation was done using the straight forward Principle of Detailed Balance between emission and capture which only requires knowledge of recombination time; and band-offsets between the InP barrier and the QW's.

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